



IPW

PATENT  
Customer No. 22,852  
Attorney Docket No. 04329.3125

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Katsuhiko OYAMA ) Group Art Unit: 2818  
Serial No.: 10/649,940 ) Examiner: Luu, Chuong A  
Filed: August 28, 2003 ) Confirmation No.: 6236  
For: SEMICONDUCTOR DEVICE AND )  
MANUFACTURING METHOD )  
THEREFOR )  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**RESPONSE TO RESTRICTION REQUIREMENT**

In a restriction requirement dated January 31, 2005, the Examiner required restriction under 35 U.S.C. § 121 between the following groups of claims: Group I, comprising claims 18-31, characterized by the Examiner as being drawn to a method of manufacturing a semiconductor device; and Group II, comprising claims 1-17, characterized by the Examiner as being drawn to a semiconductor device. Applicants provisionally elect to prosecute Group II, claims 1-17, without traverse.

Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.

Dated: February 28, 2005

By: Reg. No. 34,731  
for Richard V. Burgujian  
Reg. No. 31,744